STRUCTURAL OPTIMIZATION & RELIABILITY OF 3D PACKAGE BY STUDYING CRACK BEHAVIOR ON TSV & BEOL & IMPACT OF POWER CYCLING ON RELIABILITY FLIP CHIP PACKAGE

By

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May 05, 2017
Abstract

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CRACK BEHAVIOR ON TSV & BEOL & IMPACT OF POWER CYCLING ON
RELIABILITY FLIP CHIP PACKAGE

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The 3D packaging is stacked of chips on top of another which is emerging as a powerful
technology that satisfies such integrated circuit (IC) package demands. Most of the stress
develops at interfaces and the interface delamination of TSV may encounter which is
mainly driven by a shear stress concentration at the point. In this study, the effect of
package structure on the failure metric of the 3D package has been studied. J-integral has
been used to quantify the crack driving force. The crack is modeled at the TSV and BEOL
(Back End of the Line) and the die-substrate thickness is varied and studied during the
chip attachment process and under Accelerated Thermal Cycling (ATC) load for optimizing
the value of die and substrate thickness. Finite Element methods have been used to
analyze the thermo-mechanical stresses and fracture parameters in TSV structures 3D
package. An optimized package structure was obtained to reduce the crack driving energy
in the TSV region and in the BEOL dielectric layer. An effort is made to understand the
mechanism of the effect of number & thicknesses of cores, FR4 and Cu layers on the
substrate has been studied through finite element analysis of mechanical interaction at the
Si/TSV regions, back-end Cu/low-k stack, and the inter-die μ-bumps during chip
attachment. Analyzed that PCB stack up significantly affect the fatigue life under Thermal
cycling, thermal shock & reflow condition.
The second half of the thesis includes research on Ball Grid Array Package (BGA) which gained popularity among the industry due to its low cost, compact size, and excellent thermal electrical performance characteristics. When an electronic device is turned off and then turned on multiple times, it creates a loading condition called power cycling. The solder joint reliability assessment of BGA is done through computational method i.e. Finite element analysis (FEA) under two different loads. In this work, the power cycling and thermal cycling act as a combined load. Three different BGA boards were used for analysis and comparison has been done to investigate the impact of thickness and copper content of board on solder joint reliability under power cycling and thermal cycling. The mismatch in CTE between components used in BGA and the non-uniform temperature distribution makes the package deform differently. Modeling of life prediction is usually conducted for ATC condition, which assumes uniform temperature throughout the assembly.
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Chapter 1: STRUCTURAL OPTIMIZATION OF 3D TSV PACKAGE

1.1 Introduction

To begin with basic definition, Electronic packaging is a science and art of providing a suitable environment to the electronic product to perform reliably, over a period. When we use the word suitable environment, it includes thermal, electrical and other green issues. It encompasses every technology associated between IC and the system [15]. The role of electronic packaging is crucial since the performance of the IC’s and the system can be properly gauged only after the electronic product has been packaged. The various levels of electronic packaging are broadly classified into:

2. Board-Level.

Chip-Level Packaging: The lowest level of packaging is the chip level. It consists of steps and processes in which a bare die is conveniently handled and packaged to use on boards, etc., since we cannot directly incorporate bare dies to use, though now it has become possible as well.

On the demand for greater portability of electronic devices, the electronics in today’s digitized industry are undergoing integration and miniaturization to become smaller and lighter for ease of its application. The electronic packaging industry is driven by the chips with more I/O’s and the state of the art multi-functionality. On the other hand, the efficiency and quality with the reduced cost and power loss must be established, which inspires manufacturer to do 3D stacking of chips. This necessitates an effective communication between the IC and the electronic system. Thus, due to low cost, small form factor and high-performance 3-dimensional integration have emerged as a boost to electronic
packages manufacturing company.

Figure 1 3D Package cross sectional image with all labeled components

1.1.1 Challenges in 3D packaging

3D packaging is the challenge of efficient utilization of CRE (Chip real estate). By using wire bonding to stack chips, only the peripheral area of silicon is being utilized. Wire bonds create power loss issues, RC delay and only utilizes peripheral I/Os, with reduced multifunctionality. These packages are realistic solutions of 3D packaging, but more functionality and more input and output, less RC delay can be achieved through TSV. 3D IC technology offers the advantages of design flexibility, high bandwidth, smaller footprint, efficient utilization of chip real estate (CRE), functional integration, etc., with Through Silicon Via technology posing more scope with its shorter die-to-die interconnects, low RC delay and parasitic resistance. 3D packaging has couple of other variations, i.e. 3D IC. When 2 chips using wirebonds are connected in 3D packaging, only limited number of I/Os on the periphery are utilized. Utilization of the chip area efficiently is one of the challenges faced by 3D wire bonding. Also, power loss and RC delay increases. TSV provides an alternative to such problems. 3D TSV technology is at the heart of 3D integration and
stacking of dies. In a typical TSV package, a thin silicon wafer is drilled with through holes, and dielectric SiO$_2$ is deposited along the inside walls of the holes, and then the hole is filled with Copper. When the length of the interconnect is less, the resistance and power loss is less with faster signal processing time. Also, there are more input and output ports in TSV which lead to improved functionality. Hence we incorporate TSV’s to make 1000’s of i/p and o/p in a very small area. TSV technology is the future which drives 3D packaging. However, there are some ongoing issues related to heat removal, structural integrity, chip package interaction in TSV, which are under research and development.

### 1.1.2 Limitations of TSV Technology

Heat is the major problem in electronic devices and in 3D packages, removing heat from the system is a big challenge. The heat trapped in between the stacked die is difficult to remove and cause many failures. If the heat cannot be successfully removed from the system, then due to CTE mismatch of different materials like silicon, copper, there will be thermal stresses developed. [3, 5]

![A typical TSV package](image)

Figure 2 A typical TSV package

the TSV, there is a zone called ‘Keep Out Zone (KOZ)’ in which active transistors cannot be placed because of the developed thermal stress. This area isn’t being put to effective utilization. Since the TSV’s go through chips, and chips have transistors, the transistors cannot be placed in a thermally stressed area, since it won’t function in that area. It is challenging to remove heat from the chips which are stacked. Due to the heat, we have thermal stresses developed at the interfaces of different materials, which causes structural
integrity issues like cracking, warpage, etc. Different materials try to expand and compress according CTE values. Also, the interface of silicon/silicon dioxide is brittle and hence crack can form at the Cu TSV and Si/SiO\textsubscript{2} interface. One of the methods to minimize the issue is to determine the critical areas across the length of the TSV, and fracture mechanics can be used to determine the modes of cracking prevalent along the TSV/Si interface.

<table>
<thead>
<tr>
<th>Material</th>
<th>Young's Modulus [Gpa]</th>
<th>Poisson Ratio</th>
<th>Coefficient of Thermal Expansion (CTE) [ppm/°C]</th>
</tr>
</thead>
<tbody>
<tr>
<td>Silicon</td>
<td>169</td>
<td>0.26</td>
<td>2.3</td>
</tr>
<tr>
<td>SiO\textsubscript{2}</td>
<td>75</td>
<td>0.17</td>
<td>0.5</td>
</tr>
<tr>
<td>Copper</td>
<td>117</td>
<td>0.3</td>
<td>16.7</td>
</tr>
</tbody>
</table>

Table 1 Material Properties of Si & Cu

whole reason fracture mechanics is being used is because stress concentration equation cannot handle any flaw which has sharp corners. When you have elliptical or square holes, stress concentration is present. It is being addressed by linear elastic theory. Fracture mechanics is coming since at the crack tip, stress becomes infinity. And hence, stress intensity factor is coming into play.

This study focuses on analysis of structural integrity during chip attachment process of a 2-die 3D TSV package to gauge the stress intensity factors in TSV/Silicon interface thereby highlighting the prevalent modes of cracking in TSV. Second part of the study deals with the effects of the die and substrate thickness on the stress intensity factor arising in the TSV with respect to design changes.

1.1.3 Fracture Mechanics Application to TSV Package

From Analysis, engineers have found that cracking is one of the primary reasons most of structures and components start to fail [24]. The relationship between fracture, stress, cracks and toughness was first introduced by Griffin in 1920. The concept of strain energy release rate was proposed by Irwin in 1950s. When the strain energy release rate reaches
a critical value, crack propagates. The stress intensity factor (K) also works on a similar approach as the strain energy release rate. It can predict the state of the stress (stress intensity) near the crack tip due to the developed stresses (Remote or residual) [25]. The size, location of the crack, sample geometry and other factors affect the magnitude of stress intensity factor K. [5]

\[
\sigma_x = \frac{K}{\sqrt{2\pi r}} \cos \frac{\theta}{2} \left[ 1 - \sin \frac{\theta}{2} \sin \frac{3\theta}{2} \right]
\]

\[
\sigma_y = \frac{K}{\sqrt{2\pi r}} \cos \frac{\theta}{2} \left[ 1 + \sin \frac{\theta}{2} \sin \frac{3\theta}{2} \right]
\]

\[
\sigma_{xy} = \frac{K}{\sqrt{2\pi r}} \sin \frac{\theta}{2} \left[ \cos \frac{\theta}{2} \cos \frac{3\theta}{2} \right]
\]

1.2 Motivation & Objective

In 3 dimension packages, TSV technology is used. In TSV packages, a thin silicon wafer is drilled with holes and dielectric SiO\textsubscript{2} is deposited along the inside walls of the holes, which are further filled with copper. Removing heat from the system with TSV’s is a challenge, which creates an issue. Else, the CTE mismatch of different material will cause thermal stresses to be developed. Results in forming keep out zone where active transistors cannot be placed. TSV package has some critical stress areas like SiO2/Cu interface, and Silicon, which may lead to crack. There will be reliability issues due to these cracks. Work is done to obtain a relation between crack location and K1, K2, K3. Also, the relation between J-Integral, substrate thickness and die thickness are obtained. ANSYS 17.2 bundle is used for modeling and simulation and finite element analysis (FEA) is used to calculate stress intensity factor (SIF) at the crack interface. [1, 2, 3, 5]
1.3 Outline

ANSYS 17.2 is being leveraged for modeling all types of cracks. Quarter symmetry TSV package is modeled in same software, which was used to simulate the reflow condition and thermal cycling to analyze the various stresses developed within the TSV package. The temperature boundary condition subjected to the package was 200°C. The sub-modeling technique was used to analyze the copper core of the TSV. The cracks are modeled at a different position on TSV and different dielectric layers of BEOL to study crack behavior. Die and substrate thickness was varied to study the behavior of stress intensity factor and J-integral. Nine cracks were modeled along the TSV with the same direction. Two independent loading conditions were tested and J-integral variation was studied by varying the substrate and die thickness. Two independent loading conditions are Reflow condition and Thermal cycling.

1.4 Model Description

2 die 3-D flip chip package along with the TSV has been studied with respect to the crack propagation analysis. The response of this package after connecting substrate and the chip has also been studied. TSV has a diameter of 10μm including 0.5μm of the area covered by a dielectric. To avoid the adverse effects of silicon efficiency, the TSV is restricted to less than 4 percent. Mirza et al. and Chirag et al. have put forward a novel approach that demonstrates how reasonably computational time can be maintained. There are 3 steps that play a vital role in simulation. Initially, a global model on the compact scale is formulated and solved. The results from this solution are used to generate boundary conditions to the sub model 1 which is part of the critical region having detailed features (for example practical μ-bump interconnections and TSVs). [8, 11] These boundary conditions are applied on the sub model 2 which is part of the sub model 1. To prevent rigid body motions, a center node at the bottom is fixed and normal displacement with respect to the symmetric faces are constrained. Using linear elastic material properties
from Rajmane et al, all the materials except copper (TSVs and BEOL) and solder (SAC305) are modeled. [6] Using Anand’s viscoplastic model and considering the creep and plastic deformations (representing secondary creep), solder is modeled as rate dependent viscoplastic material. To describe the inelastic behavior of lead-free solder, Anand’s viscoplastic constitutive law has been used. Anand’s law has an impact on a total of nine material constants $A, Q, \xi, m, h, a, s, \hat{s}$ (all of which are extracted from the curve fitting experimental data) that are used throughout the solder strain-rate and temperature sensitivity. [5]

![Figure 3 Global model with highlighted solder bumps and TSV from sub model 1](image)

**Figure 3** Global model with highlighted solder bumps and TSV from sub model 1

![Figure 4 3D TSV array model](image)

**Figure 4** 3D TSV array model
Figure 5 3D TSV model without die to show solder & TSV array

Figure 6 3S TSV model with effective block

Table 2 Anand’s Constants for SAC305

<table>
<thead>
<tr>
<th>S. No.</th>
<th>Anand’s Constant</th>
<th>Units</th>
<th>Value</th>
</tr>
</thead>
<tbody>
<tr>
<td>1</td>
<td>$s_0$</td>
<td>MPa</td>
<td>1.3</td>
</tr>
<tr>
<td>2</td>
<td>Q/R</td>
<td>1/K</td>
<td>9000</td>
</tr>
<tr>
<td>3</td>
<td>A</td>
<td>Sec$^{-1}$</td>
<td>500</td>
</tr>
<tr>
<td>4</td>
<td>$\xi$</td>
<td>Dimensionless</td>
<td>7.1</td>
</tr>
<tr>
<td>5</td>
<td>m</td>
<td>Dimensionless</td>
<td>0.3</td>
</tr>
<tr>
<td>6</td>
<td>$H_0$</td>
<td>MPa</td>
<td>5900</td>
</tr>
<tr>
<td>7</td>
<td>$\delta$</td>
<td>MPa</td>
<td>39.5</td>
</tr>
<tr>
<td>8</td>
<td>n</td>
<td>Dimensionless</td>
<td>0.03</td>
</tr>
<tr>
<td>9</td>
<td>a</td>
<td>Dimensionless</td>
<td>1.5</td>
</tr>
</tbody>
</table>
Table 3 Anand’s Constant for Effective Block in the Compact Model

<table>
<thead>
<tr>
<th>S. No.</th>
<th>Anand’s Constant</th>
<th>Units</th>
<th>Value</th>
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<tbody>
<tr>
<td>1</td>
<td>$S_0$</td>
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<tr>
<td>2</td>
<td>$Q/R$</td>
<td>1/K</td>
<td>9000</td>
</tr>
<tr>
<td>3</td>
<td>$A$</td>
<td>Sec$^{-1}$</td>
<td>500</td>
</tr>
<tr>
<td>4</td>
<td>$\xi$</td>
<td>Dimensionless</td>
<td>7.1</td>
</tr>
<tr>
<td>5</td>
<td>$M$</td>
<td>Dimensionless</td>
<td>0.3</td>
</tr>
<tr>
<td>6</td>
<td>$h_0$</td>
<td>MPa</td>
<td>5900</td>
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<tr>
<td>7</td>
<td>$\hat{S}$</td>
<td>MPa</td>
<td>3</td>
</tr>
<tr>
<td>8</td>
<td>$N$</td>
<td>Dimensionless</td>
<td>0.03</td>
</tr>
<tr>
<td>9</td>
<td>$A$</td>
<td>Dimensionless</td>
<td>1.5</td>
</tr>
</tbody>
</table>

1.5 Loads and Boundary Conditions

Figure 7 Symmetry region and supports

Figure 8 uniformly distributed thermal load throughout the body
1.5.1 Assumptions
• Each layer in the package is perfectly bonded to other.
• All materials except solder alloy (SAC305) are modeled using linear elastic material properties.
• Time and temperature dependent material properties were used from Anand’s Viscoplastic Model to capture the inelastic behavior of SAC305.
• All components considered stress free at 200°C (reflow temperature).

1.5.2 Boundary Conditions
• Symmetry boundary conditions were taken at the Quarter symmetry faces.
• Common vertex of the PCB was fixed (All DOF zero) to restrict any rigid body motion.
• Reflow process for chip attachment to the substrate has been simulated – 200°C to Room at 30°C /min.

1.6 Crack Modeling

Crack propagation is placed in a different location along the cylindrical silicon die interposer where the TSV and copper passes. In this experiment, silicon and silicon dioxide are covered as the critical area on TSV interface. Therefore, the crack is modeled successfully along the silicon die/Cu interface. This is the prominent region for critical stresses acting where more chances of crack to be developed.
All modeling and formulation of radial horizontal crack for the TSV package are done using ANSYS 17.2 bundle. The tetrahedron mesh profile is used here and only semi-elliptical cracks can be a model on the exterior surface using the software. The global model as a compressive model is subjected to same reflow conditions. The sub model 1 has been cut in two half and simulation is done with same reflow conditions. The crack has been modeled in the sub model 2 which is one of the symmetrical halves of sub model 1. The sub model 2 was again subjected to the same reflow condition with
importing cut boundary constraints from the sub model 1.10 divisions with equal space have been taken for simulation of the crack where the total edge length of TSV is 95 μm. All the simulations are done along the length of TSV in sub model 2 with an equal division of 9.5 μm. When it is attached to the substrate, reflow condition is taken for thermal loading in 3D TSV package from 200°C to room temperature (for Pb-free SAC305 Alloy). The plot for the relation between stress intensity factor (SIF) (i.e. $K_1$, $K_2$, $K_3$) and crack location have been shown in this study. Also, the relation between crack size, crack length and $J$-integral is shown in the plot. The results show that the TSV area is much affected by mode 1, mode 2 and mode 3 cracking. To avoid radial crack, $K$ should be less than $K_c$, i.e. $K<K_c$ where $K_c$ is fracture toughness of silicon.

![Figure 12 Total deformation of Global Model](image)

1.7 J-Integral

J-integral is used to calculate the strain energy release rate per unit fracture surface. It is not path-independent of while loading elastic-plastic material. Rice J.R., 1968, showed that the J-integral is a path independent line integral and it represents the strain energy release rate of non-linear elastic materials. The value of $J$ is determined by calculating the area under load versus deflection curve which can be seen in figure 14. [4, 5, 7]
\[ J = \int_{\Gamma} \left( W \, dy - T \, \frac{\partial u}{\partial x} \, ds \right) \]

\[ W = W(x, y) = \int_0^e \sigma_{ij} \, d\varepsilon_{ij} \]

Figure 13 line integral around crack tip

Figure 14 J integral explanation (Load vs Deflection plot)

Where \( W \) is the strain energy density per unit volume, \( ds \) is an infinitesimal element of the contour arc length, \( \Gamma \) denotes any contour path surrounding the crack tip, and \( T \) and \( u \) are traction and displacement vectors along \( \Gamma \) Curve.
The analysis result shows that the normal stress (in the Z direction in our case) is positive across the middle area of the silicon/ copper interface. The stress distribution data is obtained after simulating under reflow conditions. The middle area of TSV is influenced to Mode 1 fracture, which is determined from the plot shown. The value $K_1$ increases at the start and then decreases. It is positive in the middle region (Figure 16). Crack on mode 2 is predominant in the top region of the interface (Figure 17). In figure 18, from the plot between $K_3$ and the crack location, the top and bottom portions of the TSVs are more susceptible to mode 3 fracture, as the value of $K_3$ is lower in the middle region. $K$ depends on the load and crack geometry.
Figure 16. Silicon dies/Cu stress distribution with K1 plot

Figure 17 K2 Crack location plot.
Maximum stresses were investigated at a different location of TSV copper core and deposited a layer of SiO2. It has observed that the copper core has more deformation and von-mises stress which is shown in figure 20. So, for the further study, crack was modeled on the copper core and all analysis was done.
Reflow soldering is the common method of attaching microelectronic devices to printed circuit board. Solder paste is used to attached the electronic component. Here, crack was modeled along the TSV and reflow thermal load is applied to the 3D package assembly. In reflow condition, the thermal load is applied at 200°C and in 350 seconds it brought to the room temperature i.e. 25°C. Figure 21 show the variation of stress on TSV with an increase in substrate thickness. Two combinations of the set have been shown in figure i.e. die with 0.1mm and 0.4mm thickness. When substrate thickness is 0.2mm then it shows maximum stresses, which are the worst combination of die and substrate thickness to be used. After 0.4mm substrate thickness for both die thickness, the stresses stabilize and remain same with less value.
The main aim of this work is to study the variation of J-Integral with package assembly structure. Figure 22 shows the variation of substrate thickness keeping dies thickness 0.1mm. J-integral value decreases with the increase of substrate thickness and remains same after 0.4mm. The relation shown in figure 22 is for horizontal crack modeled at three locations of TSV and relation for vertical crack is shown figure 21.
1.9.2 Thermal Cycling:

Thermal cycling is a most common method to check strength electronic device assembly against the thermal load. It is conducted to determine the ability of components and solder joints and interconnects. The method of thermal cycling was referred from JEDEC standard JESD22-A104D. Experimentally this test is done in an environmental chamber with the same condition mentioned in standards. Devolved mechanical stresses can be used to investigate the solder joint or assembly reliability. The temperature varies from -40°C to 125°C for 10800 sec. the dwell and ramp time is 15mins. A total of three cycles was applied to the package. Like reflow condition, crack was modeled on the TSV core at different location and variation of J-integral was studied with respect to substrate thickness and with changing top die thickness. Figure 24 shows the variation of J-integral value for the different size of the substrate for two different top die size. In this study, two cracks were modeled at the top and bottom of TSV. When the thickness of top die is 0.1mm the variation of j integral value was noted. The J-integral value decreases with increase in substrate thickness and then increase to some extend and stabilize after 0.4mm thickness. Similarly,
for 0.4mm die thickness, j integral value decreases and then remain same after some limit. The red circle in below figure is the optimized region for substrate thickness against one crack propagation.

Figure 24 J Integral variation on TSV with substrate thickness

Figure 25 modeled nine crack on TSV surface at different location
Nine cracks were modeled on the TSV core surface at distance of 11 micron with the same dimension. The variation of j integral of each crack is shown in Figure 26. The j1, j2 … j9 is the different location of crack on TSV starting from the top. The red box shows the optimize value of substrate thickness for 0.1 mm die thickness.

![J-integral vs substrate thickness plot along the TSV when die thickness is 0.1 mm](image)

Figure 26 J Integral vs substrate thickness along TSV core for top die thickness 0.1 mm under thermal cycling

Similarly, for top die thickness of 0.4 mm, j integral value has been noted for each crack by changing substrate thickness. It is observed that the 0.4 mm substrate thickness is optimized value mentioned in figure 27 in the red box. J-integral value for each crack decreases with the increase of substrate thickness.
Figure 27. J-integral vs substrate thickness along TSV core for top Die thickness 0.4mm under thermal cycling

J-integral value is line integral of the crack tip. So, per literature survey, the value of J-integral should increase with an increase in crack size. For a detailed analysis of the study on 3D TSV package, crack size was increased and the j integral value has been noted. Figure 28 shows the relation of crack perimeter and j integral value.
Also, the variation of maximum equivalent elastic strain value has been noted for different crack size. The relation between strain and the crack perimeter is shown in figure 29. The maximum strain value increases first and then decreases up to a certain limit. After 7-micron crack perimeter, the strain stabilizes and remain same with an increase in crack size.
The impact of the thermal load on J-integral for cracks on TSV surface is also studied. The upper limit of thermal cycling has been changed and varied to create a new profile as shown in figure 30. The maximum or upper temperature limit was taken from 105°C to 205°C with an interval of 20°C, therefore 6 different thermal cycling profile was created.

![Figure 30 Different thermal cycle profile](image)

For each profile load, J-integral value for all nine-cracks starting from top to bottom of TSV is noted. The variation of J-integral with respect to maximum temperature limit of thermal cycling is shown in figure 31. The j integral value is more sensitive from temperature range 115°C to 155°C. After 145°C, J-integral decreases till 165°C and it remains same after that. For all cracks, it shows same trend and almost same value. This test study is important to get an idea for analysis of crack propagation for different cyclic thermal loads.
Figure 31 J-integral variation with increasing thermal load

J-Integral variation along TSV for different maximum temperature limit in thermal cycling

Figure 31 J-integral variation with increasing thermal load
1.10 J-Integral Variation Due to Semielliptical Crack at BEOL

Figure 32 Typical BEOL structure

Figure 33 SEM cross section of the TSV in a 32nm high-k metal gate technology with embedded DRAM

BEOL reliability is challenging part in today’s microelectronic manufacturing industries. The bonding process of IC undergoes a large plastic deformation which requires a special attention from the modeling point of view. The low-k material in BEOL are the mechanically weak but are important for reducing the electrical losses. In place of gold wire bonding, copper wire bondings are used. As copper has a higher yield stress than gold [12], higher
forces act on a mechanical weak structure. The thermomechanical reliability of BEOL is as important as solder bumps, TSVs, and other components. The stability of the J-integral value obtained from the FEA is important to avoid a misunderstanding of the cracking energy. To study the impact of thermal load on crack at different layers of dielectric, BEOL stack up is incorporated. In sub-model shown in figure 33, 11 layers consisting of 5 metal layer and 6 dielectric layers alternatively stacked on each other. Each layer is 1.4micron in thickness. Similarly, to TSV, the same type of study has been done here. Leveraging finite element modeling, we have modeled semi-elliptical crack on a different dielectric layer of BEOL. The study will show the variation of J-integral of crack from top dielectric layer to bottom layer. The sub-modeling technique is used for analysis and fracture tool for modeling crack. Figure 34 shows all sub-models used and the cut boundary condition imported to it. [12]
Continuation of scale miniaturization of electronic components in semiconductor industries for improved device performance, multi-level interconnects of Copper/low-k stacked structures, adopting the damascene module, are being introduced into the next generation IC chip in order to meet the requirements of reducing high RC delay. The BEOL is comprised of copper and low-k dielectric stacked structures as shown in figure 35 which are regarded as a composition of Multi- thin films. The low-I material has lower elastic modulus and poor adhesion compared to another dielectric material. When temperature loads are applied, there is a possibility of crack growth due to a mismatch in coefficient of thermal expansion (CTE) and the elastic modulus of the layers. [13]
Figure 36 shows the mesh modeling of the crack size on the top dielectric layer of BEOL. Similar crack location and size are done for other layers too. A semi-elliptical crack with 0.5 micron major axis and 0.1 micron minor axis was modeled. Further, the thermal load applied to the model is reflow condition starting from 200°C to room temperature. Each dielectric layer shows a significant reaction to thermal load from each other. Figure 37 shows the stress distribution on 4 different layers. It can be seen from the contour that the bottom dielectric layer (i.e. dielectric layer 6) shows minimum stress and dielectric layer 5 shows maximum.

![Figure 37 Equivalent stress distribution on dielectric layer of BEOL](image)

The j integral value has been noted for a crack at different layer and the variation is shown in figure 38. Crack at Low-k electric layer 1 show the maximum j integral value due to a CTE & E mismatch between dielectric and silicon die. The value increases as we go down to second last layer from bottom low-k layer. Minimum j integral value has been noted for the bottom dielectric layer.
Further study includes the substrate thickness optimization and identifying the best dimension against crack propagation. We increased the substrate thickness from 0.1mm to 0.6mm by an interval of 0.1mm and noted j integral of crack at top dielectric for each dimension. The plot between J-integral and substrate thickness is shown in figure 39. The J-integral value shows maximum for 0.3mm substrate thickness and after 0.4mm substrate thickness, it gets stabilized. From the analysis, we can conclude that substrate thickness of 0.4mm is the best fit against crack propagation at BEOL.
1.11 3D Package Substrate Stack-Up Study

- Substrate composition plays a vital role in the reliability of any package.
- In this study, different stack up was analyzed by changing copper core thickness by keeping total substrate thickness constant.
- As the core thickness increases, $\Delta W$ also increases which is inversely proportional to life to failure.
- Copper content makes PCB/substrate more rigid.

![Figure 40](image1.png)

Figure 40 Five different substrate stack up

![Figure 41](image2.png)

Figure 41 Change in plastic work on corner solder bump for all stack up
The package, PCB, and crack modeling were done successfully. The variation of radial crack or crack propagation along the TSV Cu core and on low-k dielectric layers of BEOL has been successfully studied. The cut boundary condition from the global model and sub model were used for simulation. The variation of J-integral and other parameters were studied for a different combination of substrate and top die thickness. The J-integral value is used in calculating strain energy release rate per unit fracture surface area and is determined with respect to crack size. Six different type of thermal cycle profiles were created and variation of J-integral value has been studied. The variation of crack size has also been successfully leveraged to investigate its effect on stress and strain distribution and found that it was directly proportional to J-integral, whereas the relation between J-integral and top die-substrate thickness shows an inversely proportional relational property up to a certain limit of thickness. For 0.1mm die thickness, 0.3mm substrate thickness is most reliable against crack propagation and for 0.4mm die thickness, 0.4mm substrate thickness is most reliable. This combination creates a zone of reliable area of substrate thickness from 0.3mm to 0.4mm. In further, the impact of reflow condition on crack at different low-k dielectric layer was studied. The relation between a substrate thickness and j integral of crack at a dielectric layer is obtained. This study is important for optimizing the package geometry under different loading condition and understanding of crack propagation depending on structural integrity. Different crack size at a different location can be studied as per requirement following the same concept.


2.1 Introduction

BGA is a type of Surface Mount Technology packages. BGA is used extensively due to its robust design with many interconnects and improved connectivity with lower thermal resistance. Intensive research and development on BGA motivate us to study in detail about the layer stack up for the corresponding boards. This variety of material in a single package results in building into a complex system and increasingly retains elevated levels of reliability. Reliability is dependent on numerous factors like the operation of the device, power consumption, heat dissipation and the environment (ambient temperature, temperature changes, environmental strains).

Types of BGA Packages.
Based on the material used and connectivity and other features, the BGA package is classified into 5 types.

- MAPBGA – Molded Array Process Ball Grid Array
- PBGA – Plastic Ball Grid Array
- TEPBGA – Thermally Enhanced Plastic Ball Grid Array
- TBGA – Tape Ball Grid Array
- Micro BGA

2.2 Motivation & Objective

The buildup layer of PCB affects the reliability of solder joints; it affects the creep strain range, stress range, creep strain energy density ranges and the thermal fatigue life [9]. The solder balls on a populated PCB absorb all the strains due to the expansion of the package and by the PCB in thermal excursions. At high temperatures, there is a high
possibility of the solder joint to fail due to the CTE mismatch between the PCB and the package [1]. Also, the stiffness of a PCB is higher than the package which affects the reliability of a solder joint. [13] In this work, the study of the effect of RCC and FR4 prepreg layers on solder joint failure for two different PCB is presented. To analyze the failure, we use ATC as the test. The simulations are run for the temperatures loading from -40°C to 125°C, and dwell and ramp time of 15mins. The work includes two types of BGA boards, using RCC and FR4 as the prepregs at the outermost layers. In this work, we have investigated the board level reliability of these two different boards. Finite Element Analysis (FEA) is used to determine the fatigue co-relation parameters such as elastic strain, stresses, directional deformation and accumulated volume average plastic work to predict the characteristic life of the package.

Figure 42 120ZQZ boards with FR4 and RCC Laminate
Figure 43  Layout and design for 120 pin BGA

The above layout is the package dimension of BGA with 120 solder ball. The correct dimension of the package and PCB is important for analysis.
Figure 44 shows a clear picture of the components of the Ball Grid Package. The package basically comprises a copper pad on the top and bottom side of the solder bump. On the die side, the silicon die is attached which is further attached to polyimide layer with an adhesive layer in the middle. The solder mask is present both, the PCB side and the substrate side as shown in the schematic.

Figure 45 BGA Assembly model with labeled component names

The dimension from the drawings, X-Ray images, and the cross-section images are considered in creating a 3D model of the BGA Package. The FE modeled BGA package is shown in figure 45. Symmetry allows for an octant symmetric model resulting in
significant savings of computational time. The PCB layout (prepreg layer and the number of copper layers inside the PCBs) is determined by cross-sectioning the PCB as shown in figure 46. The detailed PCB with the layers is modeled inside a sub model. The PCB comprises of 1-6-1 configuration which means the PCB comprises of 8 copper layers where copper layers contribute to form a core layer of the PCB. The prepreg layer is present in between the PCB core layer and the outermost copper layer as shown in figure 46.

![Figure 46 Layer Stack-ups of 1 mm BGA Board](image)

11x11 pin Micro-star BGA package with PCB (two prepregs, FR4 and RCC) thickness of 1 mm were tested for temperature loading ranging from -40°C to +125°C with 20 min dwell and ramp time. [1] From figure 47, 48, it’s important to test both the package and board sides of solder joint for analysis. In this work, plastic work is calculated in two sides, i.e. top and a bottom portion. To reduce simulation time, dwell and ramp time used for the analysis is 15mins which is considerable for the comparative study.
2.3 Material Characterization

Material characterization is a very important step in FE Analysis of boards. For lumped analysis, it is necessary to predict precise material properties for the boards. Specifically, in this study, we are going to calculate CTE, Modulus of Elasticity and Poisson’s ratio for the board using lumped approach. Various test setups were used to calculate material properties.
2.3.1 Thermo-Mechanical Analyzer (TMA)

TMA is a device with a thermal chamber which has a good working range of temperature. TMA is used to measure in-plane and out of plane CTE of the different boards. For this experiment sample is prepared using High-Speed Cutter, samples are typically cut into 8 by 8 mm of a square shape. The samples are cut to such a dimension that it should sit below the probe inside the thermal chamber. The probe of the TMA is of Quartz, which seats on the sample and relative movement of probe gives the CTE plot. CTE can be calculated for a temperature range of -65°C to 260°C, with a temperature increment of 3°C/min. Three experiments were performed for each measurement and the average value was taken.
CTE is measured using TMA in all direction. The out of plane CTE for both the PCB board is shown in plot 1. Placing PCBs sample in different orientation under TMA’s quartz probe, we can measure CTE in a different direction. For example, in-plane CTE result is shown in figure 52. All measurements are done for temperature range -65°C to 260°C, so it can
be used for all type of thermal loads. After 115°C, cold crystallization and recrystallization process occur due to which the sample shrinks and shows a significant dip in CTE values. Afterward, sample expands again after crystallite formation above 135°C and finally melts. The decrease in sample height and viscosity can be seen after 205°C which shows the beginning of melting process.

Figure 52 Out of plane CTE measurement for both type of BGA.

Figure 53 In-plane CTE measurement for both type of BGA
2.3.2 Universal Testing Machine (UTM)

UTM is a tensile testing machine which was used to calculate the modulus of elasticity and Poisson’s Ratio of the boards at room temperature. Sample preparation was done by cutting the boards in dog-bone shaped as per the ASTM D412 Standards. The length of the dog bone sample was 100mm with the width of 16mm. The length in the middle section was 33mm and the grip section was 30mm. A force per unit length of magnitude 2 N/m is applied to the samples. The sample was held in two jaws to carry out the experiment. Extensometer was placed at the center of dog bone sample during a tensile test and the lateral deformation was measured to calculate Poisson’s ratio.

Table 4 BGA Package material properties

<table>
<thead>
<tr>
<th>Material</th>
<th>CTE (ppm/°C)</th>
<th>E (GPa)</th>
</tr>
</thead>
<tbody>
<tr>
<td>Copper pad</td>
<td>17</td>
<td>11</td>
</tr>
<tr>
<td>Die Attach</td>
<td>65</td>
<td>1.54</td>
</tr>
<tr>
<td>Die</td>
<td>2.9</td>
<td>150</td>
</tr>
<tr>
<td>Mold</td>
<td>8</td>
<td>24</td>
</tr>
<tr>
<td>Pi Layer</td>
<td>35</td>
<td>3.3</td>
</tr>
<tr>
<td>Solder Mask</td>
<td>30</td>
<td>41.37</td>
</tr>
</tbody>
</table>

All the measured values were temperature dependent. For computational analysis, all values for PCB was taken as temperature dependent for accuracy. The average fit value for CTE and Young’s modulus are given in table 2.
Table 5 BGA PCB board material properties

<table>
<thead>
<tr>
<th>Boards</th>
<th>CTE (ppm/°C)</th>
<th>E (GPa)</th>
</tr>
</thead>
<tbody>
<tr>
<td></td>
<td>x-dir</td>
<td>y-dir</td>
</tr>
<tr>
<td>PCB with RCC Prepreg</td>
<td>15.7</td>
<td>15.7</td>
</tr>
<tr>
<td>PCB with FR4 Prepreg</td>
<td>17.1</td>
<td>17.1</td>
</tr>
</tbody>
</table>

2.3.3 Dynamic Mechanical Analyzer

Figure 54 Dynamic Mechanical Analyzer

Figure 55 DMA 3-point bending attachment
Dynamic Mechanical Analysis measures the mechanical properties of materials as a function of time, temperature, and frequency. The term is also used to refer to the analyzer that performs the test. DMA is also called DMTA for Dynamic Mechanical Thermal Analysis. In DMA, this is done sinusoidal. The amount of deformation is related to its stiffness. A force motor is used to generate the sinusoidal wave and this is transmitted to the sample via a drive shaft. One concern has always been the compliance of this drive shaft and the effect of any stabilizing bearing to hold it in position.

Figure 56 Temperature dependent Elastic modulus results from DMA

Viscoelasticity is the property of materials that exhibit both viscous and elastic characteristics when undergoing deformation. The viscoelastic material properties of PCBs are characterized using dynamic mechanical analyzer (DMA). The frequency and temperature dependent complex moduli are obtained from the DMA.
In order to determine the time-dependent stress-strain state in linear viscoelastic materials, under an arbitrary loading process, the deformation history must be considered. The time-dependent constitutive equations of solid viscoelastic materials include these history effects. The load and displacement history, the loading rate are needed to determine the constants in the constitutive equations. A common form of these constitutive equations employs a Prony series. [12]
The DMA measurements were performed at 0.5 Hz, 1 Hz, 2 Hz, 5 Hz, and 10 Hz. Using the standard analysis software that comes with TA7000 software, the master curve was obtained for the wider frequency range. The complex modulus obtained from DMA using fit curve is used to get Prony series which is shown above. The Prony series [10] is imported as material properties in ANSYS. Total 10 values of relaxation moduli ($G_0$) for 10 relaxation time were taken into consideration.

2.4 Computational Analysis

Mechanics is characterized by its branches being: Theoretical, Applied, Computational, and Experimental. The Finite Element Methods are shelved under the computational branch. In this study, an octant symmetry exists and hence is utilized for savings computational time. Symmetric boundary conditions are applied to the two faces towards the inside where the geometry is split. The nature of all the properties was linear elastic, except the solder balls and the PCB. The solder balls were considered as visco-plastic and so Anand’s model was used to explain the behavior of the solder balls. SAC 305 where
The material composition is 96.5% Tin (Sn), 3.0% Silver (Ag) and 0.5% Copper (Cu) is what made up the solder ball. The Anand’s constants are given in Table 3. The PCBs were taken as linear orthotropic in nature. As mentioned in the assumptions, solder is modeled as rate dependent viscoplastic material which uses Anand’s viscoplastic model. It takes both creep and plastic deformation into consideration to represent secondary creep of the solder. Anand’s law consists of nine material constants $A$, $Q$, $\xi$, $m$, $n$, $h_u$, $a$, $s_u$, $\dot{s}$.

\[
\frac{d\varepsilon_p}{dt} = A \sinh \left( \frac{Q}{\xi} \right)^{\frac{1}{m}} \exp \left( -\frac{Q}{kT} \right)
\]

\[
\dot{s} = h_0 \left( \frac{B}{|B|} \right)^n \exp \left( -\frac{Q}{kT} \right) \frac{d\varepsilon_p}{dt}
\]

\[
B = 1 - \frac{s}{s^*}
\]

\[
\dot{s}' = \dot{s} \left[ \frac{1}{A} \frac{d\varepsilon_p}{dt} \exp \left( -\frac{Q}{kT} \right) \right]^n
\]

Table 6 Anand’s material Constants for SAC 305

<table>
<thead>
<tr>
<th>Constant</th>
<th>Name</th>
<th>Unit</th>
<th>Value</th>
</tr>
</thead>
<tbody>
<tr>
<td>$s_0$</td>
<td>Initial Deformation Resistance</td>
<td>MPa</td>
<td>3.3</td>
</tr>
<tr>
<td>$Q/R$</td>
<td>Activation Energy/Universal Gas Constant</td>
<td>1/K</td>
<td>9400</td>
</tr>
<tr>
<td>$A$</td>
<td>Pre-exponential Factor</td>
<td>sec$^{-1}$</td>
<td>4.0 e+08</td>
</tr>
<tr>
<td>$\xi$</td>
<td>Multiplier of Stress</td>
<td>Dimensionless</td>
<td>1.5</td>
</tr>
<tr>
<td>$m$</td>
<td>Strain Rate Sensitivity of Stress</td>
<td>Dimensionless</td>
<td>0.303</td>
</tr>
<tr>
<td>$h_0$</td>
<td>Hardening/Softening Constant</td>
<td>MPa</td>
<td>2.0e+05x(6.894 757e-03)</td>
</tr>
<tr>
<td>$\xi$</td>
<td>Coefficient of Deformation Resistance Saturation</td>
<td>MPa</td>
<td>$2.0e+05 \times (6.894757e^{-03})$</td>
</tr>
<tr>
<td>------</td>
<td>-----------------------------------------------</td>
<td>-----</td>
<td>----------------------------------</td>
</tr>
<tr>
<td>$n$</td>
<td>Strain Rate Sensitivity of Saturation</td>
<td>Dimensionless</td>
<td>0.07</td>
</tr>
<tr>
<td>$a$</td>
<td>Strain Rate of Sensitivity of Hardening or Softening</td>
<td>Dimensionless</td>
<td>1.3</td>
</tr>
</tbody>
</table>

2.5 Methodology & Meshing

Meshing is one of the most critical steps in the FEA. Larger the number of elements results in the better approximation in the solution. Excess number of elements may cause around off error in some of the cases. To avoid this error the meshing should be fine or coarse in appropriate region. Mesh sensitivity analysis can be considered to reduce the computational time while maintaining the accuracy in the solution. Here in this study different methods are used to mesh the model with fine elements while maintaining the connectivity between the elements. Initially the meshing is done with a set of elements and later the number of elements is doubled and compared. If the results are close enough the initial configuration is used to solve the model to save the computational time. If the solution is different for both the cases, then mesh refinement is done until the results are converged [10]. Different types of elements are used such as 2D and 3D elements based on the application of the analysis.

Basically, to get a detailed stress strain contours near the critical parts of the body sub modeling is done. In some cases, it may occur that the mesh is too coarse to provide the better results near the critical areas of the object where the stress is higher. Sub modeling is also known as local global analysis or cut –boundary displacement method. Cut
boundary is the method where the critical area is recognized or the part of the body where the stress is higher is determined and the part is sliced from the global model for further analysis. The boundary condition is imported from the global model for the analysis of the sub model. The boundary condition is nothing but the displacement is calculated and is used as the boundary condition to maintain the accuracy. The figure 60 clearly explains how the sub modeling is done for the area of interest.

Figure 60 Sub-modeling concept in a pulley hub

Figure 61 BGA Global and Sub model
Detailed stress-strain contours near the critical parts of the body sub modeling are done. In some cases, it may occur that the mesh is too coarse to provide the better results near the critical areas of the object where the stress is higher. Sub-modeling is also known as local global analysis or cut-boundary displacement method. The cut boundary is the method where the critical area is recognized or the part of the body where the stress is higher is determined and the part is sliced from the global model for further analysis. The boundary condition is imported from the global model for the analysis of the sub model. Here also, the sub-modeling technique was used for analysis. The detailed global model was created. [1] [5] A submodel from the global model is sliced as shown in figure 61. The impact of thermal load is highly active on the corner solder ball. The submodel was created as shown in figure 61 which includes half corner solder ball. Coarse mesh simulation is done for global model and cut boundary constraint is imported to submodel where mesh sensitive analysis was done. The figure 63 shown below is the imported boundary condition on the connected surface. [3] [4]
Thermal cycling loading was applied for -40°C to 125°C. A total of three cycles with a complete cycle of 60min, with 15min ramp and 15min dwell, were applied and the temperature profile is shown in plot 64.

2.6 Load & Boundary Conditions

The Boundary imposed on the global model is shown in the figure. Since the octa symmetric model in used the faces are applied with symmetry boundary condition. The center node is fixed i.e., Uz = 0, to prevent rigid body motion. The thermal condition used for the simulation is the same thermal condition used to obtain the BLR data. The temperature profile used is shown in the figure below. The simulation is run for over compete three cycles to obtain a stable stress-strain hysteresis loop. The initial stress free temperature is set to the room temperature i.e., 25°C.
2.7 Results

Lumped and layered model has been created on ANSYS 17.2 for computational analysis. Figure 61 shows the lumped model and figure 65 shows the layer by layer model referring PCB cross section measured under an optical microscope. Material properties for copper, RCC, FR4 and solder mask layer was defined separately and simulation is done keeping same meshing and one-part model for package component.

The equivalent stress distribution on the corner solder ball is shown in figure 66. It can be seen that the maximum stress developed on solder ball is maximized on the package side. In further analysis, life to failure has been compared between the top and a bottom portion.
Figure 66 Equivalent stress on corner solder joint

Figure 67 is the comparison of Von Mises maximum equivalent stress developed on the corner solder ball for PCB board with RCC and FR4 prepreg. The chart also shows the comparison of lumped and layer by layer model. Layer by layer model is more defined due to consideration of PCB content, therefore it shows more stresses and accurate stress value. The developed stress is less in PCB with RCC prepreg and laminate. The same trend can be seen in the layered model also but the difference in the value is less.

Figure 67 von-Mises equivalent stress for RCC & FR4 prepreg in lumped and layered model
Since solder demonstrates viscoplastic behavior, it was imperative to report the total equivalent strain in the corner solder to capture the effect of both elastic and plastic deformations. Chart 2 shows the maximum equivalent elastic strain comparison results for two boards. The board with FR4 prepreg show less strain compared to the board with RCC prepreg. The reason for the higher strain on the board with RCC prepreg is since it is less stiff than the board with the FR4 prepreg and consequently results in a higher strain as shown in the chart 2.

Figure 68 Max Equivalent Elastic Strain Comparison

Figure 69 Directional deformation in z direction
The directional deformation along the z-axis is shown in figure 69. It is observed that the maximum deformation is at top of the corner solder ball. The lumped model is tested and maximum directional deformation is obtained. The values for RCC and FR4 prepreg board were compared and are shown in figure 70. The board with FR4 prepreg shows less deformation in all direction compared to RCC prepreged board. Slit difference in deformation between x and y-direction is because temperature dependent CTE of the board in x and y are not identical.

![Maximum Directional Deformation](image)

**Figure 70** Maximum directional deformation in all axis

![Non-linear plastic work distribution](image)

**Figure 71** Non-linear plastic work distribution on Top portion of corner solder ball
Figure 72 Non-linear plastic work distribution on Bottom portion of corner solder ball

Figure 71, 72 shows two portions of corner solder ball. Fig 71 is the top portion which shows maximum stresses and Fig 72 is also considered for FEA, from experiments and literature review, it has been seen that even bottom portion has the possibility of crack propagation. So we have considered both top and the bottom portion of the corner solder ball to calculate average plastic work. Nonlinear plastic work on the top and the bottom portion of the solder ball is shown in figure 71, 72.

As seen from the results, the board with FR4 prepreg has less strain, but more Von Mises stress as compared to the board with RCC prepreg which has a higher strain and less Von Mises stress. Volume average change in Plastic work between cycle 2 and 3 was calculated for both the boards using Darveaux’s APDL code. [8] The stiffness of the board plays a significant role in reliability testing, the number of cycles to failure decreases as stiffness increases. [11]
Change in plastic work ($\Delta W$) for both boards

The fatigue indicator $\Delta W$ from the FEM analysis is used to calculate the number of cycles to failure using Schubert's model. \cite{2}\cite{6}\cite{7} Correlation is given below

$$N_f = \left(\frac{A}{\Delta W}\right)^k$$

Where,

$N_f =$ Predicted life cycles to failure

The constant $A$ and $k$ varies with a package to package and can be calculated using experimental results. BGA PCB with FR4 prepreg shows more change in plastic work at the top and bottom portion compared to PCB with RCC prepreg. The top portion has less number of cycles to failure. As per Schubert's correlation, life to failure is inversely proportional to $\Delta W$. Therefore, PCB with FR4 prepreg fails earlier.
2.8 Conclusion

In this work, successful characterization of PCB to predict its reliability via FEA. UTM, DMA, and TMA were leveraged to find Young’s Modulus and temperature dependent CTE. Directional deformation, Von Mises equivalent stress, and equivalent elastic strain are obtained from FEA and results were studied. From this work, it can be stated that after comparing the reliability of two available BGA boards, a board with RCC prepreg show better performance compared to a board with FR4 prepreg. The board with FR4 prepreg shows more Von Mises maximum equivalent stress and fails earlier. FR4 is still highly rated material used for PCB manufacturing because of its other benefits. RCC has high copper foil peel strength, high thermal resistance, and high glass transition temperature and highly demanded portable electronic equipment. FR4 has its special properties which are a high dielectric strength, high mechanical strength, light weight and high resistance to moisture. Depending on the demand and requirement both RCC and FR4 are used.
2.9 Reference


[7] F.X. Che and John H.L. Pang, "Thermal Fatigue Reliability Analysis for PBGA with Sn-3.8Ag-0.7Cu Solder Joints," in Electronic Components and Technology Conference (ECTC), 2004


3.1 Introduction

Consumer-electronics manufacturers are striving to reduce product size to meet this demand. Smaller, thinner, and thermally enhanced packages help achieve product miniaturization. A performance analysis has shown that Ball Grid Array BGA packages have better thermal performance than dual in-line surface mount technology (SMT) packages. Other benefits of the BGA packages are low inductance and capacitance, small package volume, smaller board routing area, and no external leads, compared to conventional leaded packages. The BGA package is a thermally enhanced standard size IC package designed to eliminate the use of bulky heat sinks and slugs. This package can be easily mounted using standard PCB assembly techniques and can be removed and replaced using standard repair procedures. The BGA package is designed so that the lead frame die pad (or thermal pad) is exposed on the bottom of the IC. This provides an extremely low thermal resistance (θJC) path between the die and the exterior of the package. This device package has gained popularity in the industry because of its superior thermal and electrical characteristics. The compact size of BGA package makes it an ideal choice for handheld portable applications and where package performance is required. To estimate the reliability of the package, an environmental stress test is used to simulate the end use environment conditions and to uncover specific materials and process related marginalities that may be experienced during operational life. Joint Electronic Device Engineering Council (JEDEC) and the Institute for Printed Circuits (IPC) have adapted, documented and standardized many of the reliability tests.

Solder joint failure is a major concern for a long time. Electronic manufacturing company is facing a serious problem because of solder joint failure. ATC is widely used for solder joint assessment in an environmental chamber or through computational analysis. ATC forces a uniform temperature distribution of the entire package, but it's not the case in real time. Die is the main heat source in PCB assembly and it creates a high-temperature
environment around solder joints. Power cycling is non-uniform temperature distribution load generated due to internal heat from die. Due to its non-uniform behavior, it gives the more realistic result. BGA package is a more heat generating package. The package dimension and its volume decide the temperature around in ATC whereas, in power cycling, power is assigned to die which decides the temperature distribution on assembly [1][2].

3.2 Objective

The main objective of this study is to analyze the solder joint reliability of BGA package when both power cycling and thermal cycling are applied. To understand the root cause of the failure in joints and method to improve the mechanical reliability of the package. Printed circuit board’s thickness also places an important role in package reliability. Here, three different thick board were used to do a comparative study. The layered model is compared with lumped model and solder joint reliability were assessed. Finding critical solder joint and obtaining life to failure for that critical solder has been done.

3.3 Power Cycling

When a device is switched on and switched off several numbers of times, stresses are induced in the system. This loading condition is called Power Cycling, whereas ATC is uniformly distributed the thermal load. JEDEC standards are used to follow standards values. The time per cycle for both loads are different but minimum three thermal cycles are needed to get correct plastic work of solder joints. [3]

Various numerical integration tools like Finite Element Analysis are used for virtual qualification to reduce development time and expenses. ATC conditions assume that the temperature is uniform throughout the assembly for predicting the life of the module. However, in practical conditions, the assembly is subjected to power cycles which result in temperature being non-uniform throughout assembly as the die is the only source of heat
generation. The difference in CTE between components results in the deformation of the package. This deformation is different when the package is subjected to ATC.

![Power Cycling Profile](image)

Figure 74 Power Cycling Profile

3.4 Methodology

Power cycling is applied in transient thermal analysis with a power density of 0.5W/mm$^3$ to die [1]. Time of one power cycle is 1600 seconds and is applied for 10800 seconds. The power cycling profile is shown in through the plot in figure 74. Figure 74 shows the coupled model in ANSYS and figure 75 is the tree of analysis. With the correct boundary conditions, power cycling is performed in transient thermal analysis and accelerated thermal cycling in the static structural analysis. The results of the transient thermal analysis are in form of temperature distribution. This temperature distribution is imported to static structural analysis as shown in figure 74. The interesting question comes in mind while transferring this load is that ‘Is my transferred results are time dependent and different for each node? so, the answer is yes! After importing load to static structural model, we can check the load for each time.
Figure 75 Transient thermal analysis coupled system

Figure 76 Power cycling - analysis tree from ANSYS model
Material characterization is a very important step in FE Analysis of boards. For lumped approach, it is necessary to predict precise material properties for boards. Specifically, in this study, we are going to calculate CTE, Modulus of Elasticity and Poisson’s ratio for the board using lumped approach. Various test setups were used to calculate material properties.

Table 7 five PCBs material properties

<table>
<thead>
<tr>
<th>PCB Thickness in mil</th>
<th>PCB Thickness in mm</th>
<th>CTE (ppm/°C)</th>
<th>E (GPa)</th>
</tr>
</thead>
<tbody>
<tr>
<td></td>
<td></td>
<td>X</td>
<td>Y</td>
</tr>
<tr>
<td>27mil</td>
<td>0.7mm</td>
<td>18.3</td>
<td>16.7</td>
</tr>
<tr>
<td>40mil</td>
<td>1.0mm</td>
<td>15.7</td>
<td>15.7</td>
</tr>
<tr>
<td>62mil</td>
<td>1.61mm</td>
<td>15.5</td>
<td>15.5</td>
</tr>
<tr>
<td>93mil</td>
<td>2.4mm</td>
<td>16.3</td>
<td>16.3</td>
</tr>
<tr>
<td>125mil</td>
<td>3.1mm</td>
<td>15.1</td>
<td>12.8</td>
</tr>
<tr>
<td>134mil</td>
<td>3.4mm</td>
<td>17.5</td>
<td>17.5</td>
</tr>
</tbody>
</table>
3.6 Load & Boundary Condition

The analysis was done in two parts. In the transient thermal analysis, a convective heat transfer coefficient is applied such that the maximum temperature in the package does not exceed 125°C. The convective heat transfer coefficient considered for this analysis is 23 W/m²·°C. This value is chosen in such a way that it tries to match the computational analysis to experimental results. The convection is applied to outer surface of the package and PCB board. Figure 79 shows how to apply convection on the outer surface of the model. The symmetry faces are left open. For the internal heat generation load, 0.5 W/mm³ is applied to die body of the package and the time-dependent profile is created. The body with applied power is shown in figure 78. The power cycle is applied for 10800 seconds, so it should be applied for the time same as an accelerated thermal cycle. Figure 77 shows the clear understanding of these two loads.
3.7 Transient Thermal Analysis

A die is the main power source or heat source in power cycling, therefore, a non-uniform temperature distributed load can be seen on the package. Figure 80 shows the obtained result from transient thermal analysis. It is the temperature distribution on the octant symmetry model of BGA package. The maximum temperature is at the die or the junction and the minimum is at the end of PCB corner.

Figure 79 convection on outer surfaces

Figure 80 Temperature distribution due to power cycling
Figure 81 shows the maximum temperature profile from power cycling. The total of seven cycles is applied for 3 hours. As packages get turn on, the temperature starts increasing for 800 seconds and at the end of dwell time power gets cut off and it cools down due to convection. The junction temperature for all PCB is shown in 82. The maximum junction temperature is found be in BGA with 0.7mm thick PCB. The thinner PCB shows lesser convection from the sides compared to thicker ones. This is only applicable for small geometries.

Figure 82 max temperature for all PCBs
3.8 Results

The complete analysis is done after finishing simulation on the static structural model. The failure we are looking here is solder failure. As temperature load applied to whole package assembly the PCB starts to bend and due to a mismatch in CTE in package and PCB, it creates stresses at the corner solder joint. The stress distribution on the solder ball can be seen in figure 83. The maximum stress is found at the corner solder; therefore, all analysis needs to be done on critical solder. The distance to the neutral point is maximum for corner solder.

![Figure 83 Equivalent stress on all solder balls, corner solder is critical](image)

![Figure 84 Critical solder top showing high-stress contour](image)
With the increase of PCB thickness, copper content also increases which makes PCB rigid. The rigid the board, the higher stresses it will put on the solder ball and eventually the solder will fail much earlier and have a lower number of cycles to failure. The different trend can be seen in PC and with the non-uniform temperature gradient, PCB deforms differently under PC. The thinner board shows more junction temperature. Figure 86 shows the change in plastic work distribution for BGA with different PCB thickness under ATC and figure 87 shows the same distribution under power cycle coupled with ATC. The traditional trend can be seen when the thermal load is ATC but the trend for PC+ATC is totally different. The internal heat and convection play vital role for deciding solder failure.
Figure 86 Change in plastic work under ATC (MPa)

Figure 87 Change in plastic work under PC (MPa)
3.9 Summary and Conclusion

This study shows some interesting results from power cycling analysis. The plastic work induced in the solder joints is assessed by subjecting the package through PC+ATC. Plastic work can be used to estimate the number of cycles it requires to initiate and propagate the crack inside the solder joint. The analysis includes solving a model with the octant symmetry BGA model under PC+ATC. It is observed that the number of cycles to failure increases with increase in thickness under PC+ATC whereas per general trend and our analysis, under only ATC the life to failure decreases with increase in thickness of the PCB boards. In power cycling, the temperature distribution is non-uniform and therefore the stress distribution is also different. The package on top of PCB generating heat creates more deformation in x and y-direction. Many analyses consider only power cycling but for more realistic analysis and better result, power cycling and ATC should be applied in combined. The results of the analysis show a significant change in the trend of the failure in solder joints. Depending on the package power and convection, the results can be different. The package geometry can affect the convection process. Many parameters are involved in the computational study of power cycling analysis, therefore, this results could not be considered as a universal trend. Being close to package or heat generating die, power cycling shows more damage to the solder joint. Therefore, this test method could be an important aspect in reliability assessment of solder joints.
3.10 Reference


[9] F. X. Che and John H. L. Pang, “Thermal Fatigue Reliability Analysis for PBGA with Sn-3.8Ag-0.7Cu Solder Joints,” in Electronic Components and Technology Conference (ECTC), 2004

Future Work

[1]. Different die stack can be studied. In this study, 2 die stack model was used for analysis but 3D packages have different geometry. How the different structure can affect the solder bump reliability and TSV reliability needs to be analyzed.

[2]. Not just the whole global model even different TSV design could be tried for reliability enhancement of 3D packages. The material used for TSV and solder bumps, this all factors are important in package reliability.

[3]. The two parts of this work can be combined which is performing power cycling on the 3D package. The 3D package is designed in such way that it should produce more power in small space which will lead to higher probability of solder failures, thermal cycling has been in used for a long time to investigate the reliability of packages but the failure due to internal heat need to study for the 3D package.

[4]. Perform CFD analysis for power cycling to identify actual heat transfer coefficient. ANSYS IcePak or fluent needs to be leveraged for performing CFD analysis.

[5]. Power cycling shows unexpected failure pattern and to validate the computation work, it needs to be validated by performing experimental power cycling. DC power unit and Power function generator can be used to create different power cycle profile.
Biographical Statement

Unique Rahangdale received his Bachelor’s degree in Mechanical Engineering from University of Pune, India, in the year 2015. He pursued his Master’s in Mechanical Engineering in University of Texas at Arlington from Fall 2015. He joined the Electronics MEMS & Nanoelectronics Systems Packaging Center (EMNSPC) under Dr. Dereje Agonafer in 2015 and developed a keen interest in reliability and failure analysis of electronic packages. His research interest includes reliability, fracture mechanics, thermo-mechanical simulation and material characterization. Due to his significant contribution in EMNSPC lab, he received EMNSPC scholarship award in August 2016. During his graduate studies, he was an integral part of the SRC-funded project where he worked closely with the industry liaisons. As a Vice-President of Surface Mount Technology Association (SMTA) UT Arlington student chapter, he was actively involved in all the events and a technical meeting of SMTA. Unique Rahangdale is author and co-author of more than 10 research papers published in well-known technical conferences. Upon graduation, Unique Rahangdale plans to pursue his career in the field of electronic packaging, mainly focusing on electronic components reliability and analysis.